DISTRIBUTED CONTROL ARCHITECTURE FOR AUTOMATED NANOHANDLING

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Abstract: New distributed control architecture for micro- and nanohandling cells is presented. As a modular system it is designed to handle micro- and nanorobotic automation tasks at semi-up to full automation level. The architecture includes different visual sensors as there are scanning electron microscopes (SEM) and CCD cameras for position tracking as well as non-optical force, temperature, etc. sensors for environmental control. It allows usage of multiple nanorobots in parallel for combined autonomous fabrication tasks. The system provides a unified framework for mobile platforms and linear actors.

1 INTRODUCTION

Handling of micro- and nanoscaled objects is an important research field in micro system technology (MST) and nanotechnology. While most MST techniques are concerned with bottom-up batch procedures for massive parallel production of micro systems (Menz, et al., 2001) micro- and nanorobotics tackles the nanoassembly task top-down by applying adapted macro scale manufacturing and control methods (Fatikow and Rembold, 1997).

This paper introduces general purpose control architecture for automated robot-based handling.

1.1 Microrobot Automation

Automation in microrobotics encounters many of the problems, which have been well studied in the domains of industrial robotics and autonomous service robotics for decades. Some of the problems are e.g. collision avoidance in path planning, error handling due to uncertainty of operations (Bennewitz and Burgard, 2000), or timing constraints which need to be met for successful automation.

However, there are some environmental challenges while operating in the vacuum chamber of an SEM. It takes several minutes to generate a high vacuum ($10^{-3} - 10^{-7}$ hPa) which is a serious time constraint. Therefore, all cell parts of a nanofabrication unit need to be inside of the SEM before operation starts, including tools and objects to be handled.

All tools, sensors and objects have to be vacuum compliant. Depending on the kind of manipulation, the materials need to be selected such that no contamination of the workpieces can occur. E.g. actors need to have low or even no abrasion.

For real-time position tracking of nanoobjects like carbon nanotubes (CNTs, typical diameter about 0.4 – 100 nm) only SEM images are available due to their high scanning rate and resolution. High scanning rates are crucial for image acquisition in closed-loop control, but they can only be archived with the tradeoff of noisy image data. All this makes real-time SEM tracking a challenging two dimensional problem (Sievers and Fatikow, 2005).

Another challenge is that there is only limited depth information available due to SEM by now. As a result approaching and depth alignment of objects and tools need to be done in a try and error manner.

Automation chain planning also needs to take the different environment and object scale into account. In contrast to large scale objects it is harder to release an object than to grip it. The reason for this "sticky finger" effect (Fearing 1995) is that adhesive forces are stronger at the scale of the gripper jaws and samples than gravity. Therefore pick and place operations need to be carefully planned.

One possible solution to overcome this problem is to use electron beam induced deposition (EBiD). One end of the gripped CNT gets fixated to the specimen holder by the deposited material of the
EBiD process just before releasing it from the gripper (Wich, et al., 2006).

2 CONTROL OF MICROROBOTS

Several microrobots have been developed for coarse and fine positioning to carry tools and objects. The major categories are mobile platforms and fixed platforms. Mobile robots are more flexible than fixed ones due to their working range, but they are harder to control (Ritter, et al., 1992; Hülsen and Fatikow, 2005). Linear actors are most often combined to a Cartesian microrobot for (x,y,z)-coarse positioning and additional fine positioning axes.

The control system of the nanohandling cell in the SEM is split into two parts: high-level control and low-level control. Low-level control continuously compares set-point and actual value and calculates parameters for actor steering signals. Low-level controllers are therefore responsible for the control of states and can process tasks as “grip object” or “move actor from point A to point B”.

Two types of controllers are used: open- and closed-loop controllers. Closed-loop controllers have continuous feedback of the current system state through sensor data while open-loop controllers just execute a command due to their internal knowledge of the current state.

High-level control is responsible for planning and execution of automation tasks and for supporting user input for tele-operation. Error handling of low-level tasks, parallelization of automation tasks and path planning are also part of high-level control.

The user interacts with the control system via a graphical user interface (GUI), which is displaying the current system state and is forwarding user input to high-level control.

Several different sensors measure continuously data within the vacuum chamber (e.g. cameras, pressure sensors, etc.). These measurements are collected and provided to low- and high-level control. Low-level control directly derives set values (e.g. actuation signals) from the sensor data, which are applied to the actuators. The update rate of the sensor data has direct influence on positioning speed and accuracy of the robot. High-level control sets configuration values to sensors and actor signal generators according to the task that needs to be performed. It also provides input for low-level control as position data values which are used as goal positions for low-level closed-loop control (Fig. 1).

The reliability of closed-loop low-level control nowadays has increased up to a level where single tasks can be done semi-automatically, and even full automation of various handling steps can be taken into account. The latter is a hierarchical process which takes place at the high-level control layer, where the sensors for tracking can be selected, and the sequence of process primitives is controlled. Execution and reliability of single process primitives is the responsibility of the low-level control layer (Fatikow, et al., 2006).

Figure 1: Control dataflow with different sensors for continuous feedback of the current system state. Actuation signals are generated by low-level control from sensor input, high-level control processes user input and sends steering signals to all components.

3 CONTROL ARCHITECTURE

3.1 Control Architecture Requirements

The rough dataflow schema for experimental setups in figure 1 needs to be met by any control architecture. All the actuators and sensors of the cell need to be included into a modular control system for successful automation. In order to be independent of a particular experimental setup this control system architecture needs to fulfill certain requirements:

- New actors can be integrated with low effort, independent of the low-level control algorithm of the actor.
- New sensors can be integrated with low effort, without the need of restructuring other parts of the architecture.
- Sensors and actors can be accessed through a common interface to prevent changes in high-level control.
The time from data acquisition till actuation needs to be sufficiently low to be able to archive the required low-level control results. Communication between units needs to be done asynchronous in order not to block parts of the systems while waiting for others. All commands issued by high-level control have to be executed providing feedback about the operation result for reliable error handling. The architecture is able to be scaled up, such that enough actors and sensors can be integrated for any automation sequence. The architecture has to allow parallel execution of several automation tasks. Depending on the process’ power requirements parts of the architecture may be distributed throughout several PCs.

This set of requirements leads to a distributed system on a common client server basis, described below.

### 3.2 Distributed Control Architecture

The system architecture applied consists of high-level control, sensor, vision and several low-level control server (Fig. 2) following a “Black Box Design” (Fatikow, et al. 2006). Every server offers an individual service which is defined by a public interface. Therefore every component in this modular control system can be easily replaced or updated independently of the other components.

![Figure 2: Software architecture connection chart. Rectangles are servers (e.g. sensor programs SePro, low-level controller LoLeC, etc.) and circles are hardware components. Automation module is part of the high-level control server.](image)

Visual feedback is provided by the vision server. It is responsible for collecting images from different sources and extracts position and orientation data (poses) of tracked objects in real-time. These poses are transmitted to the sensor server. All sensor data (e.g. pose, touchdown, force, temperature, etc.) are collected by the sensor server which is supplied by different sensor service programs (e.g. vision server). This data is provided to low- or high-level control, which act as client of the sensor server. It represents therefore an abstraction layer for sensors and builds a common interface for further processing. The different sensors may acquire their data at different update rates.

In contrast to the previous architecture (Fatikow, et al. 2006) the newly developed one has one low-level control server for every single actor. Each of the low-level control server requests the data needed for closed-loop control from the sensor server. There is a uniform interface for commands from high-level control. The advantage of this lean low-level control server approach is that single servers can be easily distributed among several PCs.

Their good maintainability is another important feature. Furthermore, it is easy to include different – e.g. fixed and mobile – robot platforms, because only the internal structure of the low-level controller has to be changed.

On the high-level control level still only poses have to be submitted through the command interface. Actors with internal sensors are included into this architecture in a way that the low-level control server provides the internal sensor readings to the sensor server and receives high-level commands.

In order not to adapt the high-level control server to every change in an automation sequence, a script language has been developed, which is described in more detail in section 4.2. These scripts get interpreted by the high-level control server and then mapped to low-level control tasks and steering signals (Fig. 1). Low-level control tasks can either be closed-loop for positioning or open-loop (e.g. gripping objects) tasks. The latter have to be monitored to check the operation results.

The proposed system architecture uses the Common Object Request Broker Architecture (CORBA) as communication framework, which is an object oriented middleware defined by the Object Management Group (OMG), and which is platform- and language-independent. There are several implementations of the CORBA standard, including some for real-time applications.

CORBA’s Interface Definition Language (IDL) is used as common language for all communication interfaces between different network components. Therefore the servers and clients in the system architecture only need to implement the required IDL interfaces to be able to communicate to each other via simple method calls.

A major advantage of IDLs is that they can be translated into different programming languages,
which enables heterogeneous software design. The communication overhead in a closed loop cycle has been evaluated to be sufficient low (< 5 µs) in a local full switched Ethernet network. Therefore the limiting time factor still remains to be the image acquisition time.

The interfaces of the client server architecture are designed to provide asynchronous communication. All control commands return unique process IDs so that delayed control feedback can be matched with the corresponding command. This part of the control feedback is crucial for successful, reliable automation. The automation scheduler will wait at synchronization points for this feedback (Section 4.1). To avoid dead-locks a timeout is issued after a sufficient time. The system has also a common time base enabling low-level control servers to decide whether sensor data is outdated or not. The clock synchronization is periodically triggered by a master clock.

Every network component is designed in a way that it can be run on different PCs, which makes the system fairly flexible. The distribution of low-level control servers is especially useful for control cycles that run in parallel because the distributed controllers do not compete for the same PC hardware resources. The control architecture may contain several sensor servers for different data, to overcome possible data acquisition bottle necks. It is possible to organize the sensor data traffic shaping a minimum update interval so that the inbound traffic of any single sensor server can be controlled.

The problem of keeping several low-level control programs maintainable is tackled by common low-level server templates which are available for different actor types. This also enables rapid design and integration of new actors. Similar templates will also be provided to sensor data acquisition server.

4 HIGH-LEVEL CONTROL

The purpose of high-level control is to processes an automation sequence or to receive tele-operation commands from a user via graphical user interface (GUI). Input information is translated into low-level command tokens called tasks and steering signals for the selection of certain sensors.

4.1 High-Level Control Design

Based on the description above the high-level controller provides tele-operation, automation, path planning, error handling and parallel execution of tasks. These different tasks are addressed in different units in our high-level control design (Fig. 3).

Main trigger for high-level control is a human controller, who inputs a tele-operation, semi- or full-automation command using the GUI.

If an automation command is received by the automation units of the high-level controller e.g. start or stop automation, a preloaded automation sequence is processed. The sequence of automation tasks is executed one by one or in parallel.

Every task has a defined set of pre- and postconditions (Section 4.2). The automation unit decides based on required resources (e.g. sensors and actors) and pre- and postconditions, whether two consecutive tasks can run in parallel. These postconditions should not be contradictive. If resource conflicts arise, a barrier approach is taken so that all parallel tasks are finished before automation of the resource critical task starts (Fig. 4).

For SEM automation these resource-critical tasks are often tasks which use the SEM as tracking sensor for two objects on different heights or if the SEM acts as sensor and actor at the same time (e.g. EBiD and a concurrent positioning task).

Figure 3: Components of a high-level controller.

Figure 4: Schematic view on an arbitrary automation task. Parallel tasks are finished before resource critical tasks get started.
At the automation unit level only goal positions are visible. The main task of the path planning unit is to break down goal positions into a discrete set of intermediate positions that approximate the trajectory of the robots. This trajectory should be time efficient since bad trajectories may lead to poor automation cycle times (e.g. rotating to the left might be slower that moving in \(x\), \(y\) direction.). Another goal of path planning is to avoid collisions with objects or other robots. For collision avoidance an environmental model is required. Path planning can be performed during the automation sequence design phase or online.

On the current development state of the system only offline path planning is supported, which is sufficient in most cases but delegates more responsibility to the designer of the automation sequence.

Subgoal positions calculated by the planning unit are sent to the execution unit as well as steering commands of the automation unit. The execution unit is responsible for execution of single actuation commands. 

First for every command received, all necessary steering signals are sent to the involved programs. These steering signals prepare all components in the system for the low-level control command that follows. For example the right camera is selected or actor subcomponents are turned on or off.

After receiving an acknowledgment for every the steering signal the low-level control command is issued to the corresponding LoLeC.

One of the major problems in micro- and nanorobotic is the high error rate of single automation tasks. Due to environmental and scale effects operations that are simple in macro automation as positioning do have a high error rate. E.g. there might well be endless positioning tries because of a too low low-level control error threshold, which was correct at a different humidity or temperature level.

\[
\varepsilon_{\text{seq}} = 1 - \prod_{i=1}^{n} (1 - \varepsilon_i) \tag{1}
\]

As in macro automation the error of a sequence is the multiplied error rate of every single automation task (Eq. 1). E.g. for a sequence consisting of 7 task each having an complimentary error rate of 10% the error rate of the automation sequence is higher then 50%.

The first step to deal with these high error rates is a reliable error detection which is the task of the feedback unit in the high-level controller. This unit receives all error conditions which occurred in the components of the system (e.g. a LoLeC) and presents them to the right abstraction level.

Another yet not implemented task for the feedback unit would be the observation of certain environmental states. E.g. a carbon nanotube (CNT) escaping from a gripper needs to be detected through visual feedback since there is no other sensorial information for this event. To cover this kind of errors the feedback unit could track the CNT through a vision sensor and rise an error condition if the CNT gets lost.

Error conditions get handled by different units in a different manner. If a collision is detected the planning unit might generate a new trajectory.

On automation unit level the error handling is performed by sweeping backwards in the automation sequence and looking for the first task with pre-conditions that meet the current system status.

If there is no possible way of handling an error automatically the automation sequence is interrupted and needs to be handled by a human controller.

The lowest level of automation i.e. tele-operation is provided by the tele-operation unit, which directly receives commands from a human controller. These commands are directly provided to the corresponding LoLeC servers. It is in the responsibility of the human controller to avoid collisions and move the robots to certain positions using “save” trajectories.

### 4.2 Script Language for Automation Sequences

Modeling a suitable automation sequence for a given handling task can be performed in three steps. First, the hardware setup has to be defined according to the requirement analysis. Then robot-based process primitives and their pre- and post-conditions have to be defined (e.g. move robot to target position if it is in range of the vision sensor). Finally, an automation sequence is to be found, which meets all pre- and post-conditions of the process primitives, avoids collisions and eventually accomplishes the automation task. Additional constraints as e.g. executing time can be taken into account as well.

The differences in process primitives between different nanohandling robot cells (hardware setups) impose the problems of how to avoid reimplementation and hard coding of process primitives and how to change the automation sequence without changing the program code.

A flexible script language has been developed, following the script based approach of Thompson and Fearing (2001). The different commands of the
language are the process primitives itself. They are implemented as sub-classes of a common task base class. This avoids reimplementation of common concepts as error handling or message protocols.

Composition and iteration are provided as general language constructs. Positions as e.g. parking or working positions for different actors can be defined as constants and later on be used in all commands.

Based on this script language arbitrary automation sequences on the predefined operators can be defined as plain text files (Fig. 5).

These sequence files gets interpreted and executed by the high-level controller automation unit. This way the automation sequences can take advantage of the underlying closed-loop control. The concept enables rapid development of different automation sequences for the same set of process primitives, while the high-level control program keeps unchanged.

```
lift(TOUCHDOWN_DIST);
move(EC,WORKING_POS);
grip(TRUE);
lift(SECURITY_DIST);
moves(DROP_POS);
```

Figure 5: Automation sequence that lifts the specimen holder, moves the robot into the focus of the electron beam an grips an object.

The language design has been chosen with regard to future application of a planning algorithm like Metric-FF (Hoffmann, 2003) to find the optimal automation sequence for given automation task.

5 CONCLUSIONS AND FUTUREWORK

This paper has presented a new distributed system architecture for controlling micro- and nanorobotic cells competitive to the system of Fatikow et al. (2006). However it scales up easier due to the lean low-level control design.

In contrast to the micro handing setup in Thompson and Fearing (2005) this system architecture is designed for micro- and nanohandling and full automation inside and outside a SEM chamber.

Aside of all positive design aspects the full capabilities of the system needs to be evaluated carefully and applied to different kind of nano-handling cells. So far only partial tests of components and component interaction have been performed.

Nevertheless subcomponents as there are the high-level controller automation unit, the sensorial parts and two low-level controllers for linear actors have shown decent control behavior.

More attention also needs to be paid to automation tasks reliability and detection of error conditions apart from positioning tasks as described in 4.1.

REFERENCES


